

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**Applicant(s):** Minhua Lu, et al.

**Examiner:** Huyen Le Ngo

**Serial No:** 10/697,760

**Art Unit:** 2871

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**Docket:** YOR920030499US1 (17075)

**For:** METHOD AND SYSTEM FOR  
IMPROVING ION BEAM ALIGNMENT  
FOR LIQUID CRYSTAL DISPLAYS BY  
A GROOVING UNDER LAYER

**Dated:** March 27, 2008

**Confirmation No:** 8778

Commissioner of Patents and Trademarks  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

**AMENDMENT**

Sir:

In response to the Office Action dated December 28, 2007, Applicants respectfully request reconsideration and entry of the following amendments and remarks herein.

**Amendments to the Drawings** are reflected in the description of Drawing amendments which begins on page 2 of this paper;

**Amendments to the Specification** begins on page 3 of this paper;

**Amendments to the Claims** are reflected in the listing of claims which begins on page 6 of this paper.

**Remarks** begin on page 9 of this paper.

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**CERTIFICATION OF FACSIMILE TRANSMISSION**

I hereby certify that this paper is being facsimile transmitted to the Patent and Trademark Office on the date shown below.

Dated: March 27, 2008

  
Steven Fischman